

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **TANIGUCHI, et al.**

Serial No.: **09/836,182**

Group Art Unit: **2827**

Filed: **April 18, 2001**

Examiner: **MITCHELL, James M.**

P.T.O. Confirmation No.: 7961

For. **METHOD OF FABRICATING SEMICONDUCTOR
HAVING THROUGH HOLE**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
Washington, D.C. 20231

Date: November 22, 2002

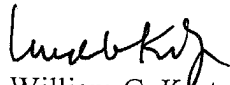
Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated August 13, 2002 for one month from November 13, 2002 to December 13, 2002.

Attached please find a check in the amount of \$110.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340. Two copies of this paper are enclosed herewith.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP


William G. Kratz, Jr.
Attorney for Applicant
Reg. No. 22,631

WGK/nrp
Atty. Docket No. **980931B**
Suite 1000, 1725 K Street, N.W.
Washington, D.C. 20006
(202) 659-2930



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